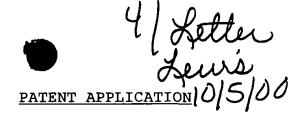
35.C14241



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re A	Application of:))					
	:	:	Exami	ner:	Unass	igned	
NOBUHIRO ITO)					
		:	Group	Art	Unit:	Unassi	jned
Applica	ation No.: Unassigned)	_			_	,
Filed:	February 16, 2000).	. • ₩				
	(Concurrently Herewith)	:)	*		7 4		
For:	MANUFACTURING METHOD	:	•				
	OF ELECTRON BEAM)					-
	APPARATUS AND SPACER,	;	Februa	ary	16, 20	00	
	AND ELECTRON BEAM)		_			
	APPARATUS	:					

Assistant Commissioner for Patents Washington, D.C. 20231

COMMUNICATION

Sir:

This application is being filed in the Japanese language pursuant to MPEP 608.01 and 37 CFR 1.52(d). Applicant will file an English translation of the specification and claims, along with a statement that the translation is accurate, an executed declaration, and any additional fees, at the time to be set forth by the Patent Office.

BEST AVAILABLE COPY

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010.

All correspondence should continue to be directed to our below listed address.

Respectfully submitted,

Attorney for Applicant

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